

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Chou San Nelson Loke, et al.  
Appl. No. : 10/781,247  
Filed : February 18, 2004  
For : SYSTEM AND METHOD OF  
CVD CHAMBER CLEANING  
Examiner : Keath Chen  
Group Art Unit : 1709

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November 13, 2007

(Date)

  
Katsuhiro Arai, Reg. No. 43,315

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed July 13, 2007, please reconsider the present application in light of the following amendments and comments.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.